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APPLICANT(S) James A. Harrington, and Veena Gopal

INFORMATION DISCLOSURE  
CITATION

(Use several sheets if necessary)

FILING DATE January 23, 2004

GROUP 2874

## U.S. PATENT DOCUMENTS

Examiner Initial	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
JD	5,815,627	9/29/1998	J. A. Harrington	385	125	
JD	5,567,471	10/22/1996	Harrington et al.	427	163.2	
JD	5,440,664	8/8/1995	J. A. Harrington	385	125	
Foreign Patent Documents						
	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION
						YES NO

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

JD		Y. Fink, J. N. Winn, S. Fan, C. Chen, J. Michel, J. Joannopoulos, and E. Thomas, "A dielectric Omnidirectional Reflector," Science, Vol. 282, pp.1679-1682 (27 November 1998).
JD		R. S Mane and C. D Lokhande, "Chemical deposition method for metal chalcogenide thin films," Materials Chemistry and Physics 65, pp. 1-31 (3 January 2000).
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JD		P. C Rieke and S.B. Bentjen, "Deposition of Cadmium Sulfide Films by Decomposition of Thiourea in Basic Solutions," Chem. Mater. 5, pp. 43-53 (1993).
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		R. Dahan, J. Dror, and N. Croitoru, "Characterization of Chemically Formed Silver Iodide Layers for Hollow Infrared Guides," Mater. Res. Bull. 27, pp. 761-766 (1992).
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		Veena Gopal, and James A. Harrington, "Deposition and characterization of metal sulfide dielectric coatings for hollow glass waveguides; OPTICS EXPRESS, Vol. 11, No 24; pp. 3182-3187; December 1, 2003.
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Examiner /Jennifer Doan/

DATE CONSIDERED 09/24/2006

\* EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.